## PARSONS HSUE & DERUNTZ LLP

JFW/9232856



## 655 Montgomery Street, Suite 1800 San Francisco, Ca 94111 tel 415.318.1160 fax 415.693.0194

Applicant(s):

Wayne G. Renken

Title:

Process Condition Sensing Wafer and Data Analysis System

Application No.:

10/056,906

Filing Date:

January 24, 2002

Examiner:

Charles D. Garber

Group Art Unit:

2856

Docket No.:

SENS.005US0

Conf. No.:

2359

Mail Stop Amendment Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Amendment (12 pages); and
- (2) Return Postcard.

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 23, 2004.

Franklin Dye

Respectfully submitted,

Peter A. Gallagher

Reg. No.47,584

Dota



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Wayne G. Renken

Title:

Process Condition Sensing Wafer And Data Analysis System

Application No.:

10/685,550

Filing Date:

October 14, 2003

Examiner:

Charles D. Garber

Group Art Unit:

2856

Docket No.:

**SENS.005US1** 

Conf. No.:

4924

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

This is in response to the non-final Office Action dated June 29, 2004, setting a period for response expiring on September 29, 2004.

Claim Amendments are reflected in the listing of claims, which begins on page 2 of this paper.

Drawing Amendments are not being made.

Specification Amendments are not being made.

Remarks begin on page 7 of this paper.

Attorney Docket No.: SENS.005US1

Application No.: 10/685,550

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